



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 19, 2024

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

LG669463569

LABORATORY GROWN DIAMOND

EMERALD CUT

9.57 X 6.50 X 4.43 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.79 CARATS

D

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG669463569

PROPORTIONS

Medium To Slightly Thick

65%

15%

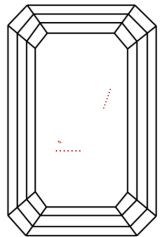
49.5%

68.2%

Long

Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

IGI

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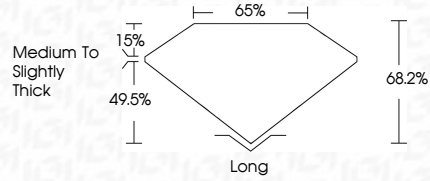
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IGI

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EMERALD CUT

9.57 X 6.50 X 4.43 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Girdle

2.79 CARATS

D

VS 1

68.2%

65%

Medium to Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

IGI LG669463569

Culet

Polish

Symmetry

Fluorescence

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